

Electronic Acknowledgement Receipt

EFS ID:	4109707
Application Number:	10689617
International Application Number:	
Confirmation Number:	4799
Title of Invention:	Method for cleaning plasma etching apparatus, method for plasma etching, and method for manufacturing semiconductor device
First Named Inventor/Applicant Name:	Satoru Okamoto
Customer Number:	26171
Filer:	Diana DiBerardino/Paul Stovenour
Filer Authorized By:	Diana DiBerardino
Attorney Docket Number:	12732-170001
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Application Type:	Utility under 35 USC 111(a)

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Submitted with Payment	yes
Payment Type	Deposit Account
Payment was successfully received in RAM	\$670
RAM confirmation Number	660
Deposit Account	061050
Authorized User	

File Listing:

Document Number	Document Description	File Name	File Size(Bytes)/ Message Digest	Multi Part /.zip	Pages (if appl.)
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1	Appeal Brief Filed	127320170001appeabriefno2.pdf	114399 01547ca4189a6d34b6c33b6608363203761a89	no	47
Warnings:					
Information:					
2	Fee Worksheet (PTO-06)	fee-info.pdf	32110 25ab0e981eececf084a363c27674d7f13e1c5d6d25	no	2
Warnings:					
Information:					
Total Files Size (in bytes):			146509		
<p>This Acknowledgement Receipt evidences receipt on the noted date by the USPTO of the indicated documents, characterized by the applicant, and including page counts, where applicable. It serves as evidence of receipt similar to a Post Card, as described in MPEP 503.</p> <p><u>New Applications Under 35 U.S.C. 111</u> If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.</p> <p><u>National Stage of an International Application under 35 U.S.C. 371</u> If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.</p> <p><u>New International Application Filed with the USPTO as a Receiving Office</u> If a new international application is being filed and the international application includes the necessary components for an international filing date (see PCT Article 11 and MPEP 1810), a Notification of the International Application Number and of the International Filing Date (Form PCT/RO/105) will be issued in due course, subject to prescriptions concerning national security, and the date shown on this Acknowledgement Receipt will establish the international filing date of the application.</p>					